



Attorney Docket No. 09792909-5921

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 2811
Jinichi SATO)
Application No. 10/828,882)
Filed: April 21, 2004)
For: Semiconductor Thin Film and Method)
of Fabricating Semiconductor Thin)
Film, Apparatus for Fabricating Single)
Crystal Semiconductor Thin Film, and)
Method of Fabricating Single Crystal)
Thin Film, Single Crystal Thin Film)
Substrate and Semiconductor Device)

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PRELIMINARY AMENDMENT

Prior to examination of the above-referenced continuation patent application,
Applicants request entry of the following amendments and remarks.

IN THE DRAWINGS

Please include the enclosed figure 16 in the present application.

REMARKS

The enclosed figure 16 was incorporated by reference from parent application serial number 09/946,898 at the time of filing of the present application. No new matter has been added.

CONCLUSION

Applicants do not believe any fees are due for this submission. However, any applicable fees can be withdrawn from Deposit Account 19-3140.

Applicants believe the application is in condition for allowance, and favorable consideration are respectfully requested.

Respectfully submitted,

By:

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FIG. 16

